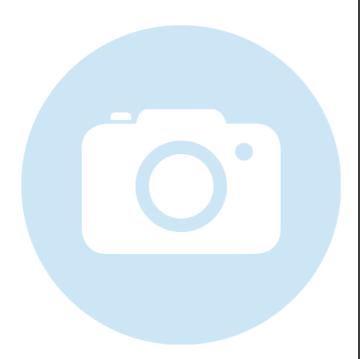


5M-S50+55CM-445-76-G02-A7.5-PS-7

Compact Laser Micro Focus Generator with elliptical Gaussian beam profile



FEATURES

Compact Laser spot with elliptical Gaussian beam profile.

■ Spot diameter: 0.009 x 0.018 mm

Wavelength: 445 nmWorking distance: 46 mm

- Micro Focus Generator for small spot widths and high power density in the focal plane
- With RS232 interface





DESCRIPTION

The laser diode beam source type 5M-S50+55CM-445-76-G02-A7.5-PS-7 produces an elliptical laser spot with elliptical Gaussian intensity distribution.

The laser has integrated electronics <u>type PS</u> with micro-controller for control of the laser output power and serial interface (RS232). The output power can be controlled using the <u>modulation input ports (TTL and analog)</u> or manually using the potentiometer.

The working distance can be adjusted by adjusting the focus setting. Please note that the spot diameter increases proportionally to the working distance. A fine-adjustment of the distance between laser and target is recommended for fine-focusing.

TECHNICAL DATA

5M-S50+55CM-445-76-G02-A7.5-PS-7



Series	5M	
Order Code	5M-S50+55CM-445-76-G02-A7.5-PS-7	
Line profile	Gaussian Intensity Distribution	
Wavelength	445 +15/-5 nm	
Laser output power	76 mW	
Laser safety class	3В	
Focussing range	35-70 mm	
Working distance	46 mm	
Spot height	0.018 mm	
Spot width	0.009 mm	
Rayleigh range	0.259 mm	
Diameter laser module	25/28 mm	
Module length	73.1 mm	
Installation length	149.1 mm	
Cable length	1.5 m	
Connector type	Lumberg SV70 IEC 61076-2-106	
Supply voltage	5 ± 0.2 V	
Max. current consumption	0.5 A	
Working temperature	15 - 40 °C	
Modulation inputs	Analog	TTL
Input resistance	9 kOhm	9 kOhm
Max. modulation frequency	0.001 kHz	250 kHz
Modulation delay ON/OFF	3000/3000 μs	0.6/0.2 μs
Rise / Fall time	200000/200000 μs	0.2/0.2 μs
Interface		RS232

ACCESSORIES

60EX-4 Eccentric key with a stroke of \pm 0.5 mm.

60EX-4-L Alternative eccentric key with long handle with a

stroke of \pm 0.5 mm.

9D-12 Screwdriver WS 1.2

RELATED PRODUCTS



LASER MODULES

Compact Laser Macro Focus Generator

SERIES 5MM

Circular beam profile andExtended depth of focus

LASER MODULES

Micro Focus Generator

SERIES 13MC

Rotationally symmetric, Gaussian beam profile

LASER MODULES

Compact Laser Micro Focus Generator

SERIES 5MC

Rotationally symmetric, Gaussian beam profile

LASER MODULES

Micro Focus Generator

SERIES 13M

Elliptical Gaussian beam profile

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